

RD-26,782

INFORMATION DISCLOSURE STATEMENT BY APPLICANT--
LIST OF ITEMS

Applicant

Mark P. D'Evelyn et al.

Filing Date

Group

(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	BA					
	BB					
	BC					
	BD					
	BE					
	BF					
	BG					
	BH					
	BI					
	BJ					
	BK					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	No
	BL						
	BM						
	BN						
	BO						
	BP						

OTHER INFORMATION (Including Author, Title, Date, Pertinent pages. Etc.)

SWD	BR	"The Effect of Carbon and Nitrogen Implantation on the Abrasion Resistance of Type IIa (110) Diamond", Anderson et al., 8th International Conference on Ion Beam Modification of Materials, Heidelberg, Germany, 7-11 Sept. 1992, Vol. 880-81, pt. 2, pp. 1451-1455
SWD	BS	"Stresses Generated by Impurities in Diamond", TR Anthony, Diamond and Related Materials, pp. 1346-1352 (Dec. 1995)
SWD	BT	European Search Report

EXAMINER

H. Radtke

DATE CONSIDERED

4/5/2008

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.